



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Takashi IGARASHI et al.

Group Art Unit: 3727

Application No.: 10/611,918

Examiner: H. SHAKERI

Filed: July 3, 2003

Docket No.: 108833.01

For: LENS MACHINING APPARATUS, LENS MACHINING METHOD, AND LENS
MEASUREMENT METHOD

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the October 20, 2008 Notice of Panel Decision from Pre-Appeal Brief
Review, the period for reply being extended by the attached Petition for Extension of Time,
and in consideration of the attached Request for Continued Examination, please consider the
following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.